



Application/Control No.	Applicant(s)/Patent under Reexamination	
10/036,140	MCCLELLAN ET AL.	
Examiner	Art Unit	
Ji-Yong D. Chung	2143	

SEARCHED					
Class	Subclass	Date	Examiner		
			-		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East (Updated search)	3/5/2006	JDC		
STIC Search report (Fast and Focused. See attached)	3/2/2006	JDC		
Double patenting search	3/2/2006	JDC		